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The Impact on Probe Pin Performance of Different Plunger Cutting Methods at Device Side

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Suzhou ■□ October 23, 2018 Shenzhen ■□ October 25, 2018



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The Impact on Probe Pin Performance of Different Plunger Cutting Methods at Device Side

Problem Statement

- Lead-free solder balls can easily cause solder migration
 - Require frequent cleaning
 - Increase production down time
 - Shorten the EOL of probe pin
 - Reduce the throughput of test operation
 - Increase the cost of testing
- One of the known reasons for heavy solder migration is inconsistent and high contact resistance (CRES) during test



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Goal and Objective

- To investigate the impact of the surface roughness of plunger on the CRES and thus solder migration onto the probe pin
 - Use different cutting tools and processes on the same device side plunger (Plunger A) design
 - Assemble the pins using the same parts from the same production lot, apart from the cut Plunger A
 - The assembled pins are mounted into common cycling jig at the same time to conduct the experiment
 - Current is passed to accelerate the solder migration
 - Measurement of CRES is taken at every interval
 - Observation of solder migration is taken after cycle test



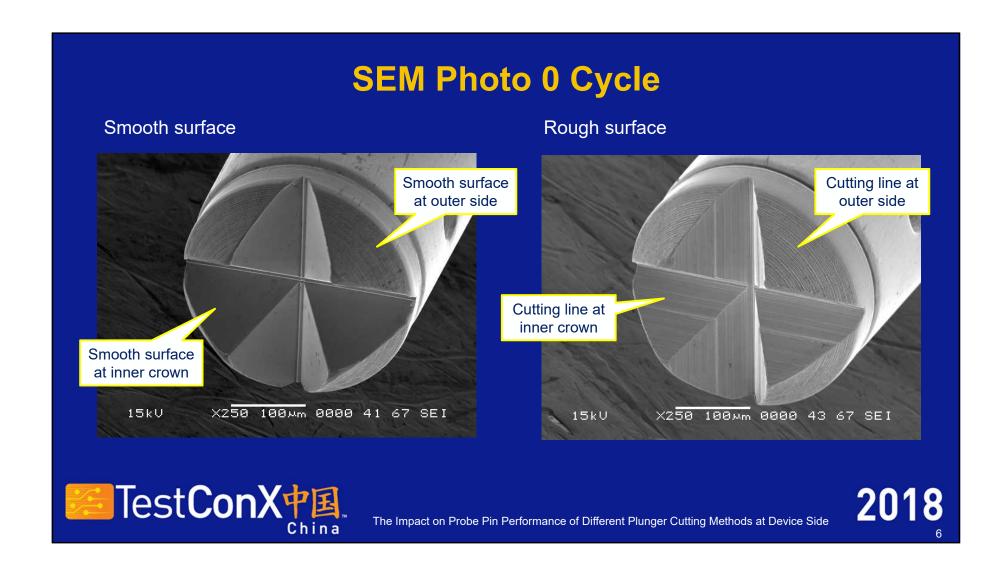
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Test Parameters

- New pin, 7 pieces each of smooth and rough surface finishing
- Current, 2.5 A @ 10 sec
- Device Simulator, SAC 105
- Total Cycle, 200
- Device Simulator movement, every cycle

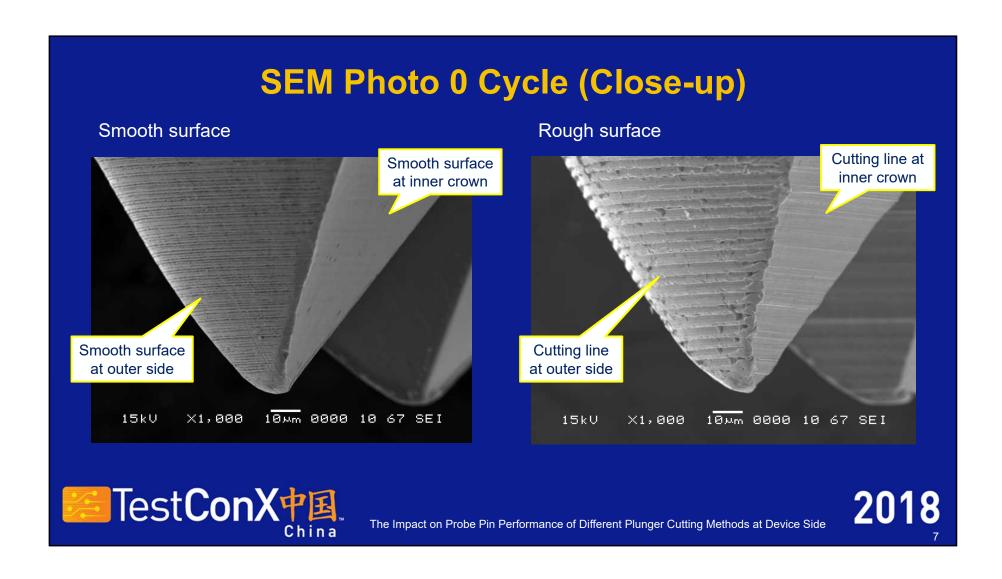


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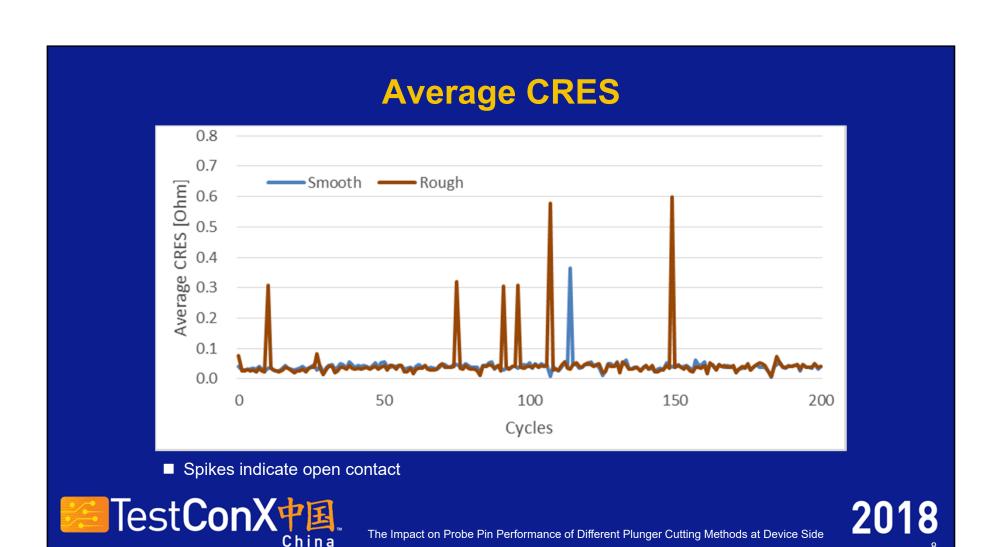
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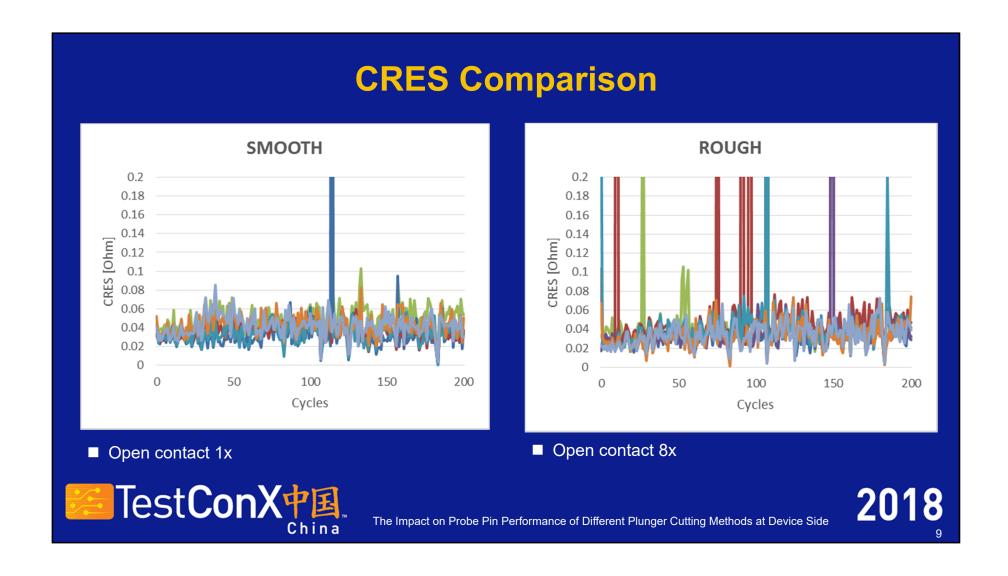
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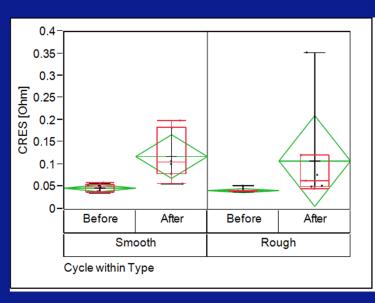


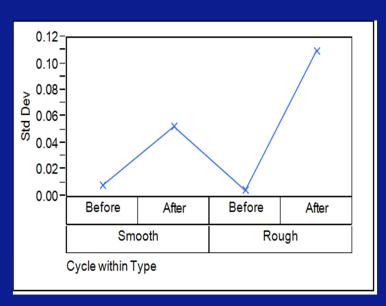
Accumulated Average CRES 12 Smooth —— Rough Accumulate Average CRES 10 8 [Ohm] 50 100 150 200 Cycles ■ Smooth surface has a lower and more stable CRES than rough surface Test**ConX中国** 2018 The Impact on Probe Pin Performance of Different Plunger Cutting Methods at Device Side

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CRES Distribution

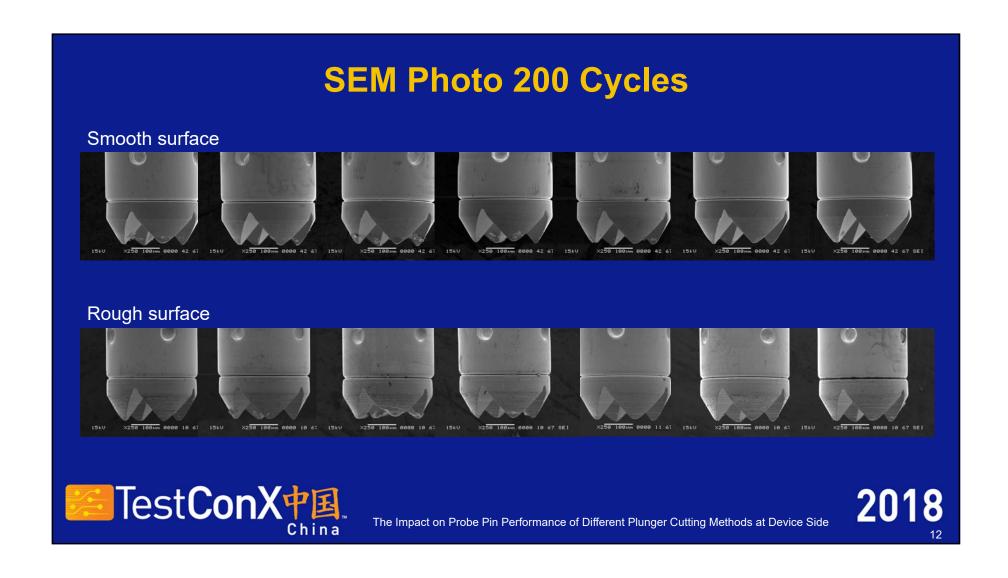


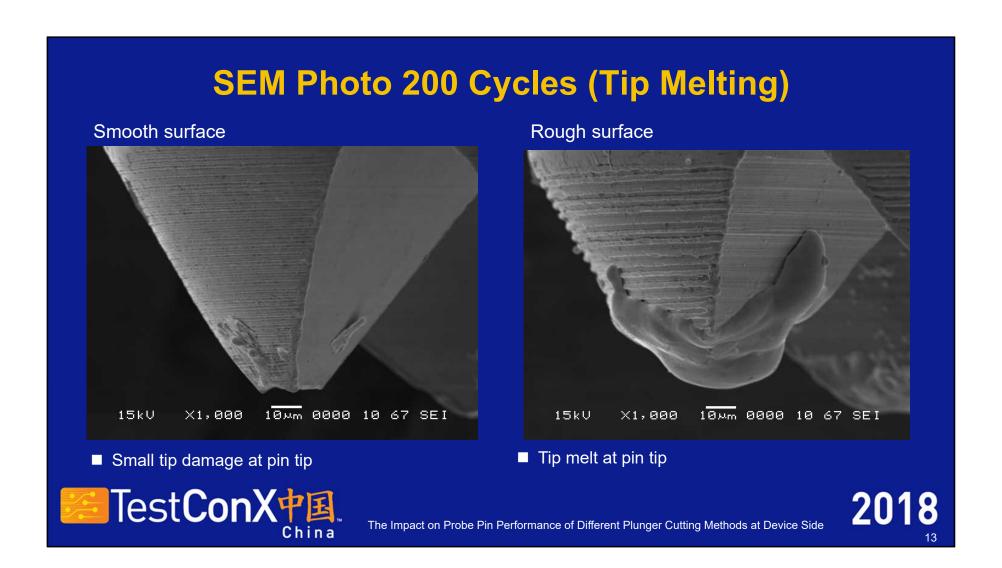


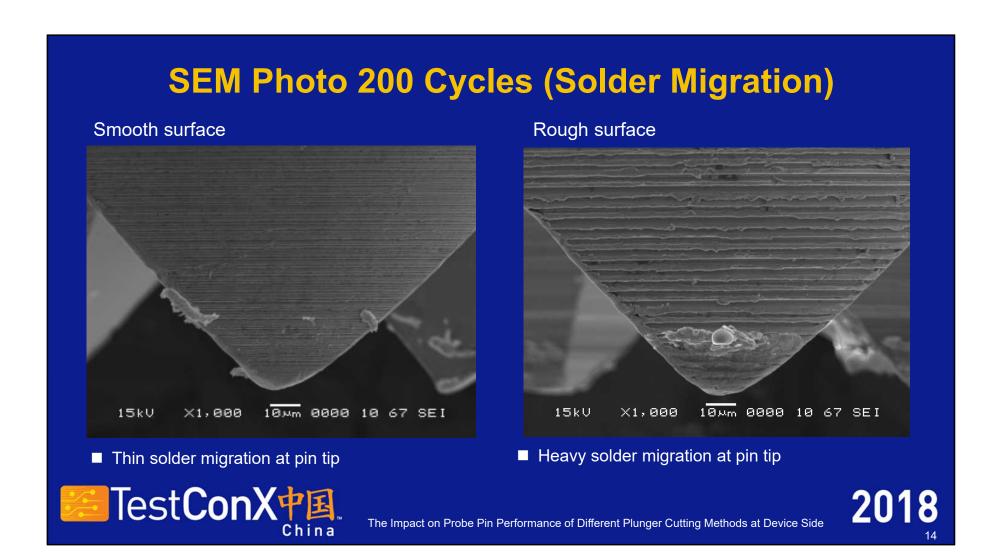
- CRES is measured by FDR machine with gold plated prober
- Smooth surface has smaller standard deviation compared to Rough surface



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Conclusion

Plunger	CRES Average	CRES Stability	Open Contact	Tip Melting	Solder Migration	Overall
Smooth						
Rough		*	*		*	*

- Smooth PA Surface has best overall performace
- Good
- **X** Bad



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